

<b>Form PTO-1449</b> <b>U.S. Department of Commerce</b> <b>Patent and Trademark Office</b>		<b>Attorney Docket No.</b> ARC920030009US1		<b>Serial No.</b> Unassigned 10/679 <sup>422</sup>	
<b>INFORMATION DISCLOSURE STATEMENT</b> (Use several sheets if necessary)		<b>Applicant (s):</b> Robert Dennis Miller, et al.			
		<b>Filing Date:</b> Herewith 9/30/03		<b>Group Art Unit:</b> Unassigned 7823	

  

U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Sub-class	Filing Date	
dt	AA	2002/0127498 A1	Sep 12 2002	Doshi et al	430	322	Apr 5, 1999
dt	AB	6,380,270	Apr 30, 2002	Yates	521	50.5	Sep 26 2000
dt	AC	5,895,263	Apr 20, 1999	Carter et al.	438	624	Dec 19, 1996
	AD						
	AE						
	AF						
	AG						

  

FOREIGN PATENT DOCUMENTS							
Document	Date	Country	Class	Sub-class	Translation Yes/No		
dt BA	JP 06-100725	Apr 12, 1994	Japan	C08J	9/28 Yes		
dt BB	WO 02/40571 A1	May 23, 2002	PCT	C08G	77/04 Yes		

  

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
dt CA	Hiroyuka Hiraoka and Tsuguo Yamaoka, Acid Hardenable, Spin-Coatable Silicon Ladder Polymer Systems As Resis Materials, Microelectronic Engineering, Vol. 13, (1991), pp. 61-64.
CB	
CC	
CD	
CE	

  

<b>EXAMINER</b> <i>[Signature]</i>	<b>DATE CONSIDERED</b> 5/26/05
------------------------------------	--------------------------------

  

<b>EXAMINER:</b>	Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant (s).
------------------	-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------

